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Leixin Meng, Qi Xu, Zhe Sun, Gaoda Li, Suo Bai, Zenghua Wang, Yong Qin

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Enhancing the Performance of Room Temperature ZnO Microwire

Gas Sensor through a Combined Technology of Surface Etching and

UV Illumination

Leixin Meng¹, Qi Xu¹, Zhe Sun¹, Gaoda Li¹, Suo Bai¹, Zenghua Wang¹, Yong Qin^{1, 2, *}

¹Institute of Nanoscience and Nanotechnology, Lanzhou University, Lanzhou 730000, China

²School of Advanced Materials and Nanotechnology, Xidian University, 710071, China

*Corresponding author. E-mail address: qinyong@lzu.edu.cn

ABSTRACT

Enhancing the performance of individual micro/nanowires based room temperature gas sensors is a big challenge for real-time detection of toxic gases. In this work, we developed a surface etching method to increase the sensitivity of individual ZnO microwire (MW) based gas sensor. The etching of the MW increases the adsorption sites for gas molecules on it by increasing the specific surface area and the surface density of single ionized oxygen vacancies. This leads to a ~20-fold increase of the gas sensor's sensitivity. When working under 148.8 μ Wcm⁻² of UV light, the sensitivity is further increased to 411%. Meanwhile, the response and the recovery time decreases to ~20% and ~2% of the values in dark condition, respectively. As a result, the individual ZnO microwire based gas sensor's performance was greatly enhanced, and it has great potential to be used as a room temperature gas sensor towards NO₂.

Keywords: Sensor; Sensitivity enhancement; Surfaces; Etching; individual microwire.

1. Introduction

Detecting toxic environmental pollutants such as NO₂ in real-time at room temperature is very important to avoid their damage to the health of plants, human beings, and animals [1]. Consequently, gas sensors incorporated into portable systems such as wearable devices and hand hold terminals are attracting considerable interest [2]. These systems require both small device size and low power consumption. Recently, gas sensors fabricated with individual micro/nanowires, which meet the

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